

Quasi-Moseley's law for UTA spectra in high-Z highly ion charge states for high power EUV & soft x-ray sources

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Abstract

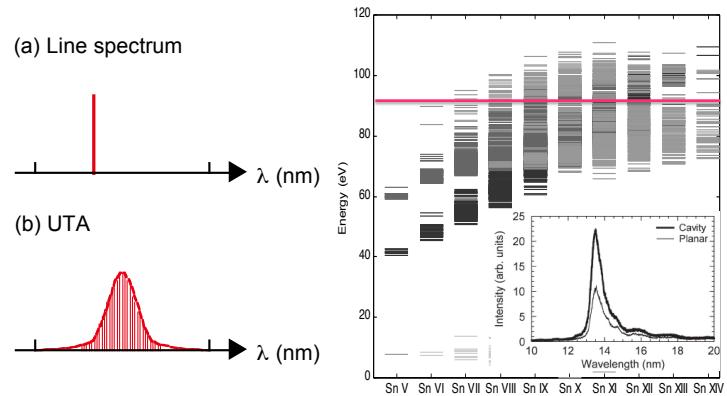
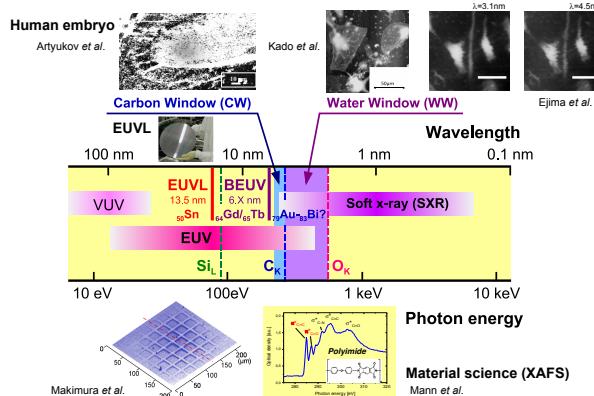
Bright narrow band emission observed in optically thin plasmas of high-Z elements in the extreme ultraviolet spectral region follows a quasi-Moseley's law. The wavelength varies from 13.5 nm to 4 nm as the atomic number ranging from 50 to 83. The range of emission wavelengths available from hot optically thin plasmas permits the development of bright laboratory-scale sources for applications including lithography, x-ray microscopy, and x-ray absorption fine structure (XAFS) determination.

Summary

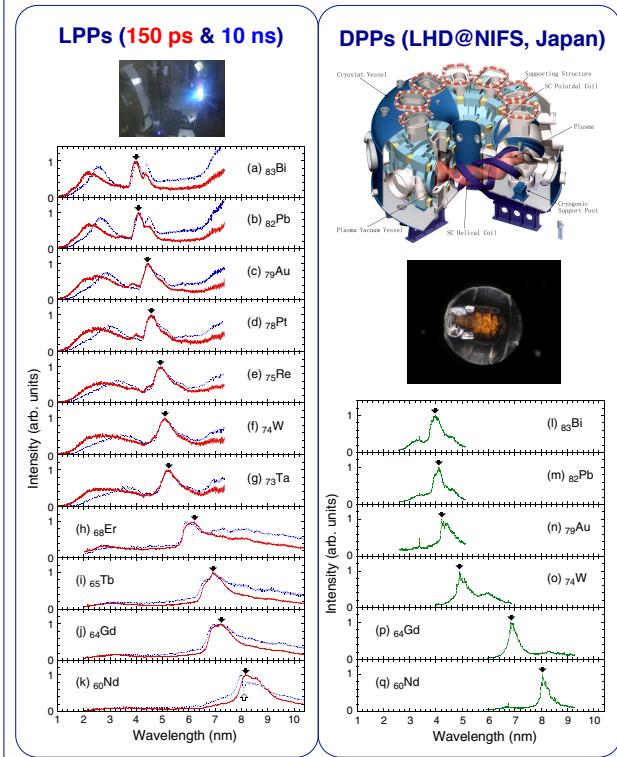
- (1) We can select the wavelength of the $n = 4-n = 4$ ($\Delta n = 4$) UTA light source by adequate Z-selection of the target element and tune it by control of the laser intensity.
- (2) Quasi-Moseley's law is useful for the estimation of appropriate elements.

$$\lambda_{\text{UTA}} (\text{nm}) = 21.86 \times R_{\infty}^{-1} (Z - 23.23)^{-1.52}$$

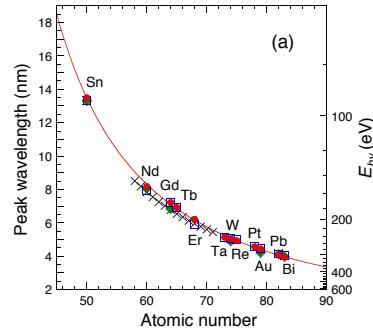
Background



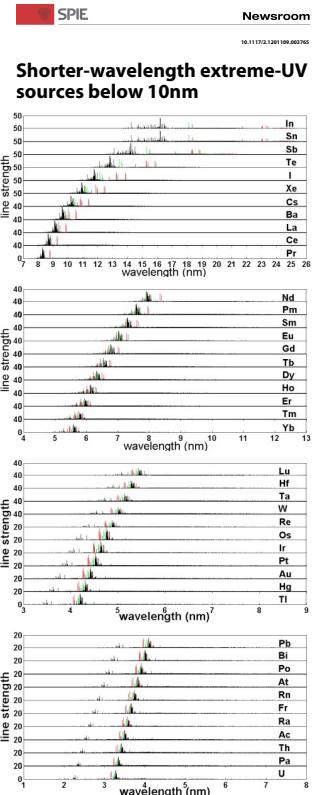
Results



$$\lambda_{\text{UTA}} (\text{nm}) = 21.86 \times R_{\infty}^{-1} (Z - 23.23)^{-1.52}$$



- Peak wavelength of $n = 4-n = 4$ UTAs (λ_{UTA}) depends on the atomic number.
- Quasi-Moseley's law was derived from the ps-LPP experimental values.
- UTA peaks of $Z = 79-83$ were in the water window and $Z = 75-79$ in the carbon window.
- $n = 4-n = 5$ UTAs observed in shorter wavelength than $n = 4-n = 4$ UTAs show the difference between pulse durations due to the difference of charge state distributions in the plasmas.
- Strong self-absorption effect was observed in the case of ^{60}Nd .



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Quasi-Moseley's law for strong narrow bandwidth soft x-ray sources containing higher charge-state ions

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